



1763

3790 USA/DISPLAY/AKT/BG
7828.7017

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
Kurita, et al.
Serial No.: 09/464,362
Filed: December 15, 1999
For: DUAL SUBSTRATE LOADLOCK
PROCESS EQUIPMENT

Examiner: MacArthur, S. #1012

Art Unit: 1763

RECEIVED
JUN 13 2002
TC 1700

Assistant Commissioner for Patents
Washington, D.C. 20231

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

Dear Sirs:

In accordance with 37 CFR 1.56, 1.97, and 1.98, enclosed please find Form PTO-1449 listing the attached references which might be deemed material to the examination of the above-identified application. The information disclosure statement submitted herewith is being filed before the mailing date of a first Office Action after filing of a Request for Continued Examination under 1.114. It is believed that no fee is due. Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-0585. A duplicate of this letter is enclosed.

Respectfully submitted,

Alan S. Raynes
Reg. No. 39,809

KONRAD RAYNES VICTOR & MANN LLP

June 10, 2002
Date

Direct All Correspondence to:
Patent Counsel
Applied Materials, Inc.
P.O. Box 450A
Santa Clara, CA 95052

Direct Telephone Calls to:
Alan S. Raynes
(310) 556-7983 (general)
(310) 871-8448 (direct)